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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Notice of Allowance Mailed: April 26, 2004

Application No.: 09/202,107
Filing Date: March 8, 1999

Applicant: Eiji Muramatsu

Group Art Unit: 2871
Examiner: Dung T. NGUYEN

Title: LIQUID CRYSTAL DISPLAY DEVICE,
METHOD OF MANUFACTURING THE SAME,
AND ELECTRONIC EQUIPMENT

Attorney Docket: 9319S-000082

Director of the United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

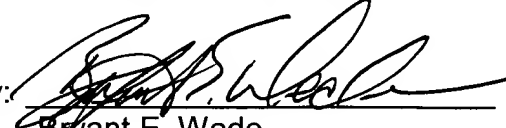
MAKE OF RECORD LETTER

Sir:

The issue fee for the above-identified allowed application was forwarded to the U.S. PTO on July 23, 2004. Please make the information set forth on the enclosed Form 1449 of record in this file. The listed documents were cited in a search report for a corresponding Japanese patent application. Applicant makes no admission that the disclosures in these documents effect the presumption of validity for the claims in this issued patent. Applicant also believes the documents are not critical to the patentability of this allowed patent application.

Respectfully submitted,

Dated: March 9, 2005

By: 
Bryant E. Wade
Reg. No. 40,344

HARNESS, DICKEY & PIERCE, P.L.C.
P.O. Box 828
Bloomfield Hills, Michigan 48303
(248) 641-1600

EV 570 162 777 US

FORM HDP-1449 (Based on Form PTO-1449)

PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Sheet 1 of 1

ATTORNEY DOCKET No.

9319S-000082

SERIAL No.

09/202,107

APPLICANT

Eiji Muramatsu

FILING DATE

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GROUP

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U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.						

FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes No	
1.		08-043846	2/16/1996	Japan		X	
2.		08-043845	2/16/1996	Japan		X	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
1.		Communication from Japanese Patent Office re: counterpart application.

*One or more of the English translation documents submitted herewith may be Abstracts only or partial machine created translations from the Japanese Patent Office. As such, the submitter does not necessarily vouch for their accuracy. Additional information may be obtained from the Japanese Patent Office web site at www.jpo.go.jp

Examiner:

Date Considered:

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.